



PATENT

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant: Cha Deok Dong

Serial No.: 10/720,457

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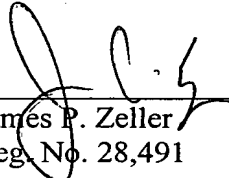
For: METHOD FOR FORMING  
DEVICE ISOLATION FILM IN  
SEMICONDUCTOR DEVICE

Group Art Unit: 2822

Examiner: Michael M. Trihn

I hereby certify that this paper is being  
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James P. Zeller  
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RESPONSE TO OFFICIAL ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the claims section begins on page 2 of this paper; and  
the remarks begins on page 6 of this paper.